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Compl te if Known Substitute for form 1449A/PTO **Application Number INFORMATION DISCLOSURE** 09/769,166 Filing Date 01/23/2001 STATEMENT BY APPLICANT **First Named Inventor** FIJOL, John **Art Unit** 2871 (use as many sheets as necessary) **Examiner Name** tbd Sheet of Attorney Docket Number 99E052

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Substitute for form 1449B/PTO Compl te if Known **Application Number** 09/769,166 INFORMATION DISCLOSURE Filing Date 01/23/2001 STATEMENT BY APPLICANT First Named Inventor FIJOL. John Group Art Unit 2871 (use as many sheets as necessary) **Examiner Name TBD** Sheet of **Attorney Docket Number** 99E052

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	OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	
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